



PATENT  
Attorney Docket No. 03180.0350

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
)  
Hiroko NAKAMURA et al. )  
)  
Application No.: 10/760,522 )  
) Group Art Unit: 2123  
Filed: January 21, 2004 )  
) Examiner: Dwain M. Craig  
For: A METHOD FOR A PREDICTING A )  
PATTERN SHAPE BY USING AN )  
ACTUAL MEASURED )  
DISSOLUTION RATE OF A ) Confirmation No.: 1093  
PHOTOSENSITIVE RESIST (As )  
amended) )

**Mail Stop Amendment**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**AMENDMENT**

In reply to the Office Action mailed December 20, 2006, the period for response having been extended to May 21, 2007 (May 20, 2007, being a Sunday) by a Petition for Extension of Time of two months and fee payment to be drawn from Deposit Account 06-0916, please amend the above-identified application as follows:

**Amendments to the Specification** are included in this paper.

**Amendments to the Claims** are reflected in the listing of claims in this paper.

**Remarks** follow the amendment sections of this paper.

**Attachments** to this paper include a copy of a PTO Form 1449 included with an

Information Disclosure Statement (IDS) submitted August 12, 2004.

05/22/2007 10:01:14 AM  
01 FC:1252 450.00 DA  
02 FC:1201 200.00 DA  
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